

Docket No.: 21776-00057-US  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Kohei Tatsumi, et al.

Conf. No. 2805

Application No.: 09/851,324

Art Unit: 2823

Filed: May 9, 2001

Examiner: N. Berczny

For: SPHERICAL SEMICONDUCTOR DEVICE  
AND METHOD FOR FABRICATING THE  
SAME

RESPONSE TO FINAL OFFICE ACTION UNDER 37 C.F.R. §1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 1, 2003

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated June 3, 2003 (Paper No. 7), the period for response having been extended by three (3) months, the following remarks are submitted for consideration by the Examiner.

**Remarks/Arguments** begin on page 2 of this paper.

A no-cost IDS has been submitted concurrently with this Response.

Deposit Account authorization is provided with the Petition for Extension of Time.

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